## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of

Yasushi YAMAZAKI et al.

Application No.: 09/970,766

Filed: For: October 5, 2001

Group Art Unit:

281レ

Examiner:

Shouxiang F

Docket No.:

110791

METHOD OF MANUFACTURING SEMICONDUCTOR SUBSTRATE, SEMICONDUC SUBSTRATE, ELECTRO-OPTICAL APPARATUS AND ELECTRONIC EQUIPMENT

LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

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Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired October 31, 2002, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 136764 in the amount of \$110.00 in payment for:

X	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
	Extension fee for response within second month pursuant to §1.136(a) (\$400.00)
	Extension fee for response within third month pursuant to §1.136(a) (\$920.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Eric D. Morehouse Registration No. 38,565

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